

# MEMS Engineer Forum 2024

SMART Society Driven by MEMS

April 17-18, 2024

KFC Hall, Ryogoku, Tokyo, Japan

Free charge for conference and exhibition

MEF 2024 will be held  
In-person format



## SPONSORSHIP Guidance

<http://www.m-e-f.info/>



## Speakers for MEF 2024

By alphabetical order of last name

Pierre-Damien Berger, CEA-Leti  
Georg Bischofink, Bosch  
Jae Yoong Cho, Enertia Microsystems, Inc.  
Jean-Christophe Eloy, Yole Developpement  
Weileun Fang, National Tsing Hua University, Taiwan  
Jessica Gomez, Rogue Valley Microdevices  
Susumu Kaminaga, SPP Technologies  
Yoshitaka Kato, Murata Finland  
Pawel Latawiec, Metalenz  
Kurt Petersen, Silicon Band  
Young Shen, Silex Beijing & Magnus Rimskog, Silex Microsystems AB, Sweden

The following affiliations are selecting the speakers:  
ColdQuanta  
KOKUSAI ELECTRIC  
Ministry of Economy, Trade and Industry  
Okmetic  
Skyworks  
Stanford University  
STMicroelectronics

..... and more speakers coming

Sponsors Type and Benefit (10% tax to be added)	GOLD	SILVER	BRONZE
	¥300,000	¥200,000	¥100,000
1 Advertisement for digital MEF Program Handout	A4 full size○	A4 full size○	A4 full size○
2 Logo on MEF Website	○	○	○
3 Logo on MEF Sign board	○	○	○
4 1-min PR Movie Run at breaktime (main hall)	○	○	○
5 Invitation ticket(s) to Networking event (Apr. 17)	2*	1*	×
6 Sp1-min PR Movie Run just before one keynote speech	○	×	×
7 Lunch ticket(s) (Apr.17&18)	3*	2*	1*
8 Meeting room usage	○	○	○
9 Registration List (limited only accepted)	○	○	×

\*If you apply by December 22, 2023, you will get double benefit for the columns with \*.

## EXHIBIT Booth

All sponsors can enjoy discount exhibit price at additional 200,000 yen for regular booth. (50,000 yen discount).

Regular Booth Spec ¥250,000 (10% tax to be added)  
Booth size: W1800mm × D900mm × H2100mm  
(Height of table: 700mm)

The following items are included in the booth.

- Back panel
- Affiliation Name Board (standardized design)
- Electric outlet 500W (2 outlets)
- Chair

Academic Booth ¥50,000 (10% tax to be added)

Start-up Booth ¥50,000 (10% tax to be added)

The size of academic and start-up will be smaller.

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Susumu Kaminaga/SPP Technologies/SK Global  
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and Information Technology  
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